Special Issue

Photon-Counting Image Sensors

Message from the Guest Editors

The field of photon-counting image sensors is advancing rapidly with the development of various solid-state image sensor technologies including single photon avalanche detectors (SPADs) and deep-sub-electron read noise CMOS image sensor pixels. This foundational platform technology will enable opportunities for new imaging modalities and instrumentation for science and industry, as well as new consumer applications. Papers discussing various photon-counting image sensor technologies and selected new applications are presented in this all-invited Special Issue. Prof. Dr. Eric R. Fossum

Guest Editors

Prof. Dr. Eric Fossum

Prof. Dr. Nobukazu Teranishi

Prof. Dr. Albert Theuwissen

Dr. David Stoppa

Prof. Dr. Edoardo Charbon

Deadline for manuscript submissions

closed (12 February 2016)



Sensors

an Open Access Journal by MDPI

Impact Factor 3.5 CiteScore 8.2 Indexed in PubMed



mdpi.com/si/6076

Sensors
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
sensors@mdpi.com

mdpi.com/journal/ sensors





Sensors

an Open Access Journal by MDPI

Impact Factor 3.5 CiteScore 8.2 Indexed in PubMed



About the Journal

Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

Editor-in-Chief

Prof. Dr. Vittorio M. N. Passaro

Dipartimento di Ingegneria Elettrica e dell'Informazione (Department of Electrical and Information Engineering), Politecnico di Bari, Via Edoardo Orabona n. 4, 70125 Bari, Italy

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), PubMed, MEDLINE, PMC, Ei Compendex, Inspec, Astrophysics Data System, and other databases.

Journal Rank:

JCR - Q2 (Instruments and Instrumentation) / CiteScore - Q1 (Instrumentation)

